

<b>Notice of References Cited</b>	Application/Control No. 10/516,602	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Savitri Mulpuri	Art Unit 2812	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,919,931	07-2005	Chae, Gee-Sung	349/40
*	B	US-6,696,363	02-2004	Lee et al.	438/681
*	C	US-4,472,458	09-1984	Sirinyan et al.	438/86
*	D	US-6,723,281	04-2004	Ueno et al.	420/503
*	E	US-6,744,486	06-2004	Kim et al.	349/187
*	F	US-2002/0008798	01-2002	Song et al.	349/43
*	G	US-2004/0238886	12-2004	Lee et al.	257/347
*	H	US-6,524,663	02-2003	Kelly et al.	427/553
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.